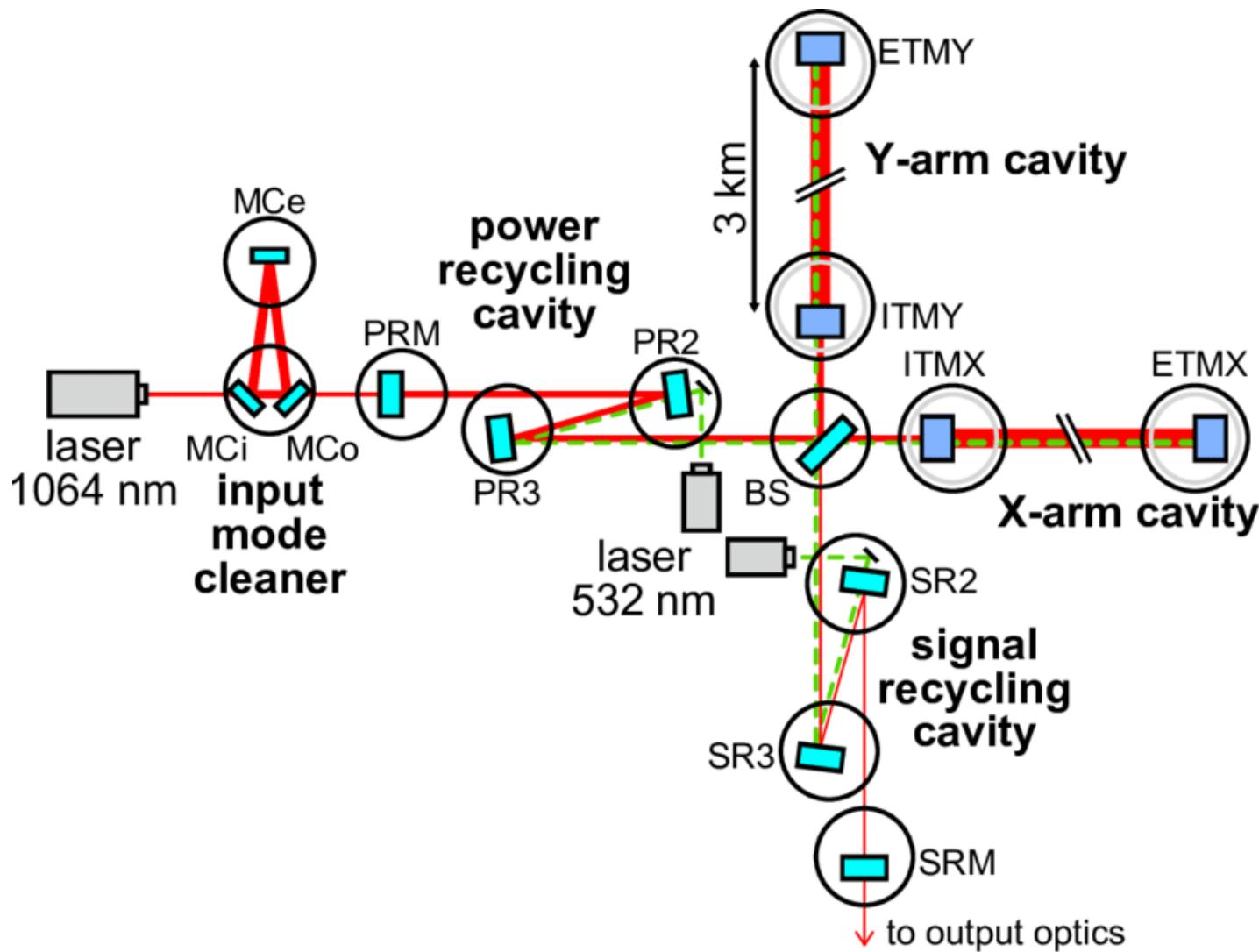




KAGRA sapphire mirror issues and current status

M. Leonardi (National Astronomical Observatory of Japan)

Introduction to KAGRA's mirrors



Sapphire mirrors:

- Two input test masses (ITMX and ITMY)
- Two end test masses (ETMX and ETMY)

Fused silica mirrors:

- One beam splitter (BS)
- Three input mode cleaner mirrors (MCi, MCo, MCe)
- Three power recycling cavity mirrors (PRM, PR2, PR3)
- Three signal recycling cavity mirrors (SRM, SR2, SR3)
- Two input mode matching telescope mirrors (IMMT1, IMMT2)
- Two output mode matching telescope mirrors (OMMT1, OMMT2)
- ...

Introduction to “sapphire”

KAGRA mirrors: Aluminum oxide (corundum)

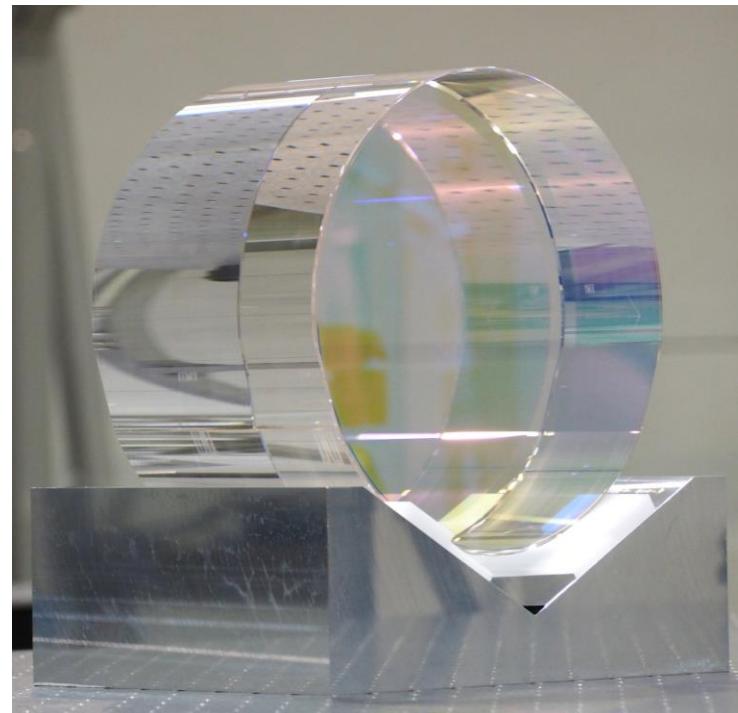
Pro:

- Very high thermal conductivity at cryogenic temperature
- Transparent at 1064nm
- High density
- Good industrial manufacture techniques
- ...



Cons:

- Second hardest material in the world
- Birefringent material (in a-axis)
- ...



How to build a mirror...

Bulk/substrate:

- Size, optical absorption, crystal orientation, refractive index variation, purity, birefringence, ...

Polishing:

- Radius of Curvature, roughness, flatness, surface defects, ...

Coating:

- Reflectivity/transmittivity, homogeneity, scattering, absorption, loss angle, ...

MIR related issues

- ITMs **transmittivity unbalance**
- ITMs **Transmitted Wavefront Error (TWE)**
maps not within specs
- ITMs **bulk birefringence**

ITMs transmittivity unbalance

Measurement from [T1809173](#)

	Specification	ITMX	ITMY
Transmission	$0.4\% < T < 0.5\%$	0.444(2)%	0.479(2)%
Asymmetry $\frac{2 T_1-T_2 }{T_1+T_2}$	< 0.01		0.077(6)

Cause:

- Non-simultaneous coating process due to polisher delay on ITMY

Consequences:

- Different arm finesse ([klog#14258](#)):
Xarm: 1456 +/- 21
Yarm: 1312 +/- 26
- Increased laser intensity and frequency noise coupling ([T2011662](#))

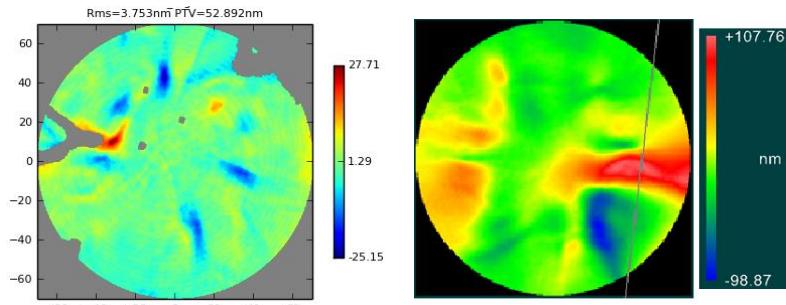
Solution:

- Re-coat ITMs

ITMs TWE maps not within specs

Measurement from [T1809173](#) ([T1808715](#), [T1910386](#), [Phys. Rev. Appl. 14, 014021](#))

	specification	vendor report	measured
ITMX	< 6nm	3.47	25.9nm
ITMY		4.07	30.1nm



Cause:

- polisher's Fizeau interferometer uses circularly polarized laser while the KAGRA detector uses linearly polarized light

Consequences:

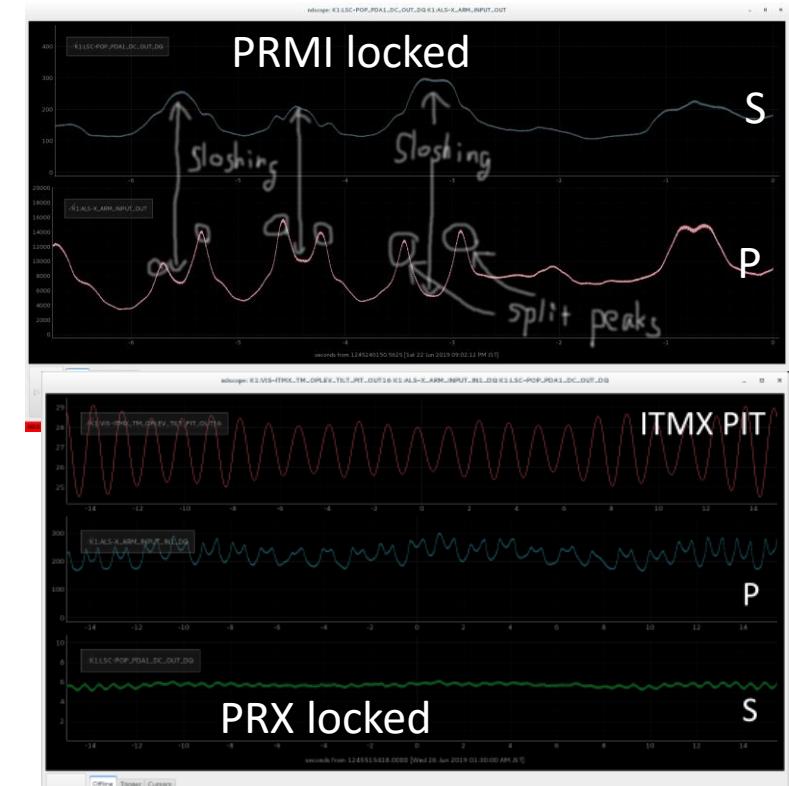
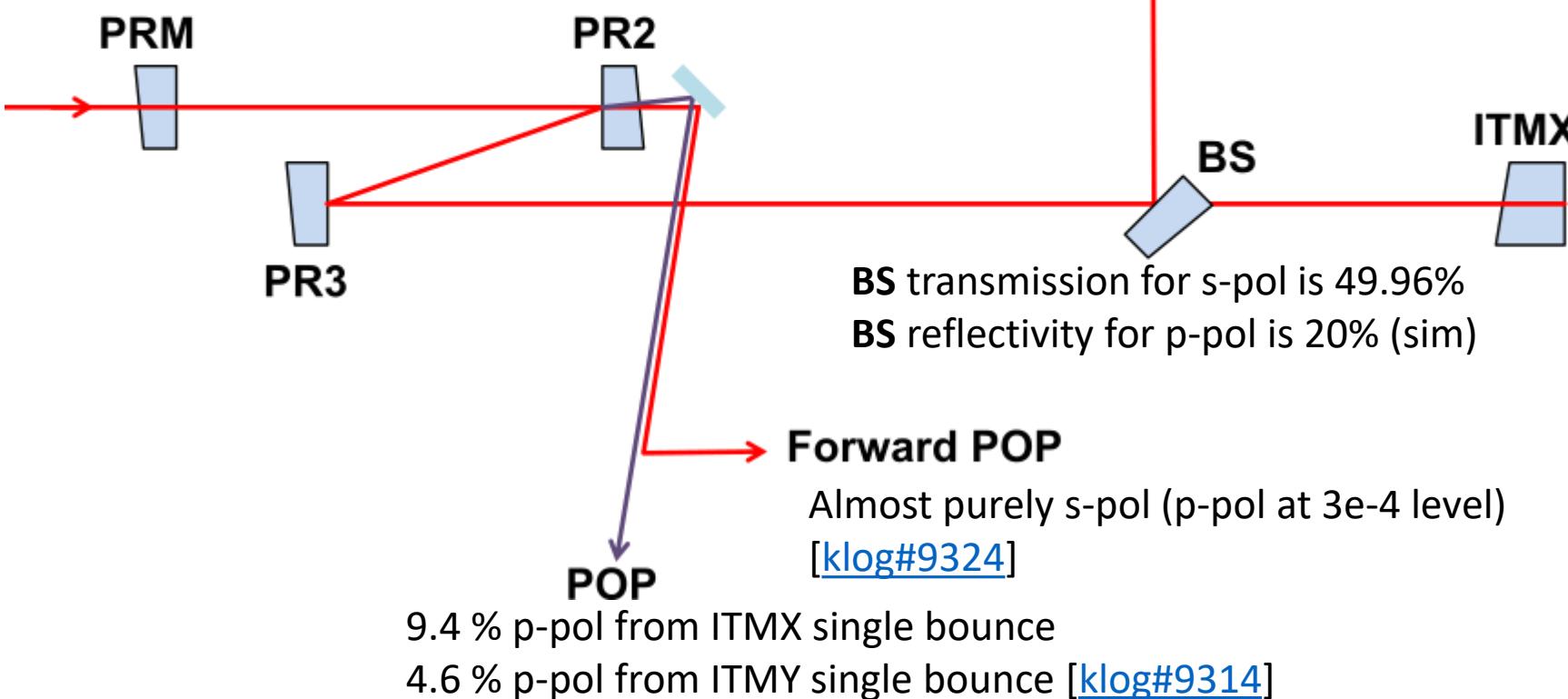
- Increased laser intensity and frequency noise coupling ([T2011662](#)) and increased HOMs at the dark port ([G1809362](#), [Phys. Rev. D 100, 082005](#))

Solution:

- Re-polish ITMs (using correct TWE map)

ITMs bulk birefringence: p-pol detected

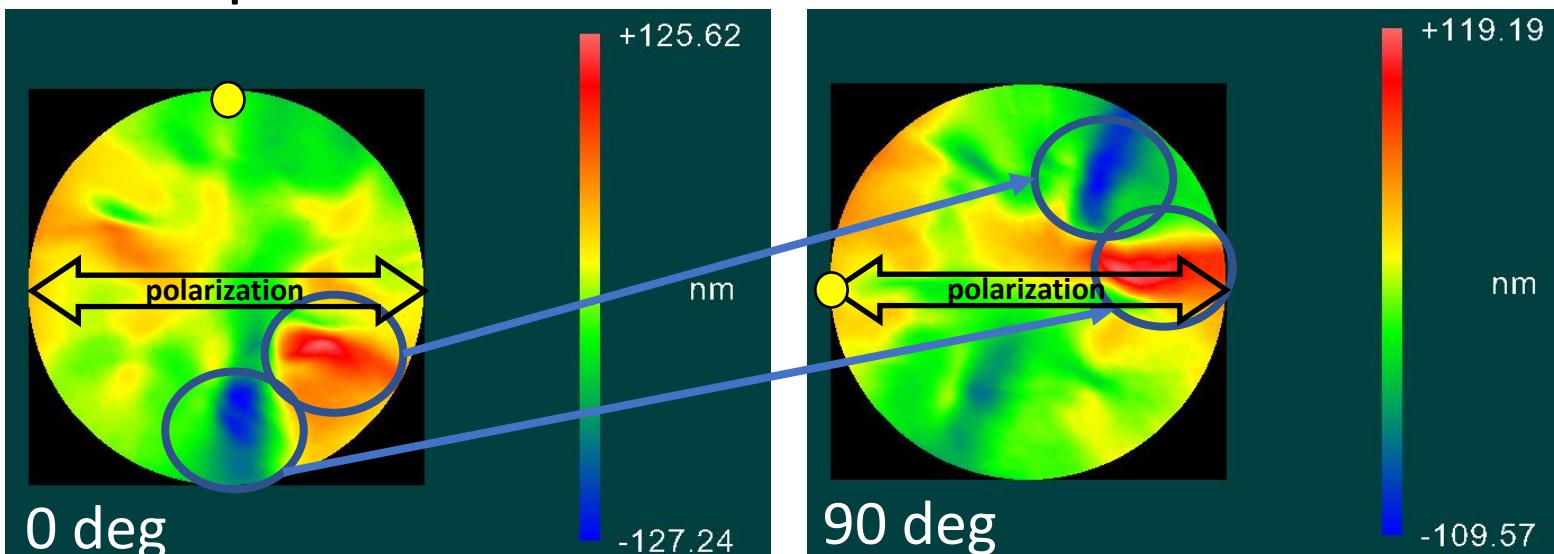
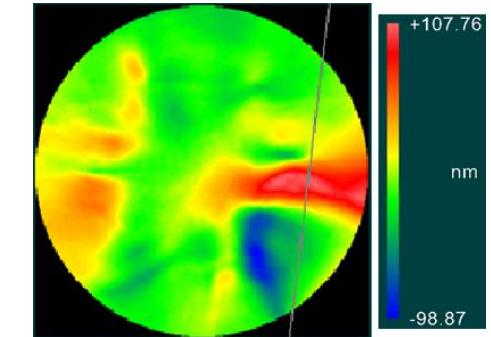
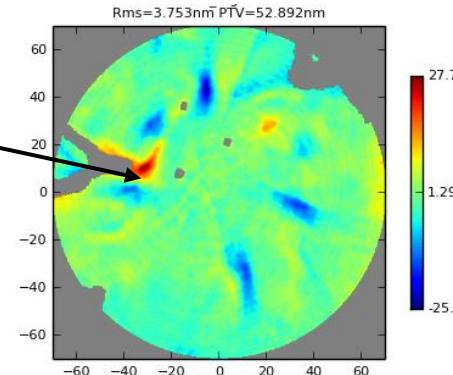
- PRC gain measured was not as expected [[klog#9300](#), [klog#9310](#)]
- ITMs reflection had some p-pol



[klog#9325]

Birefringence information from TWE maps

- TWE maps from **Zygo** and **Caltech** were different
- Different maps for different “input polarization”



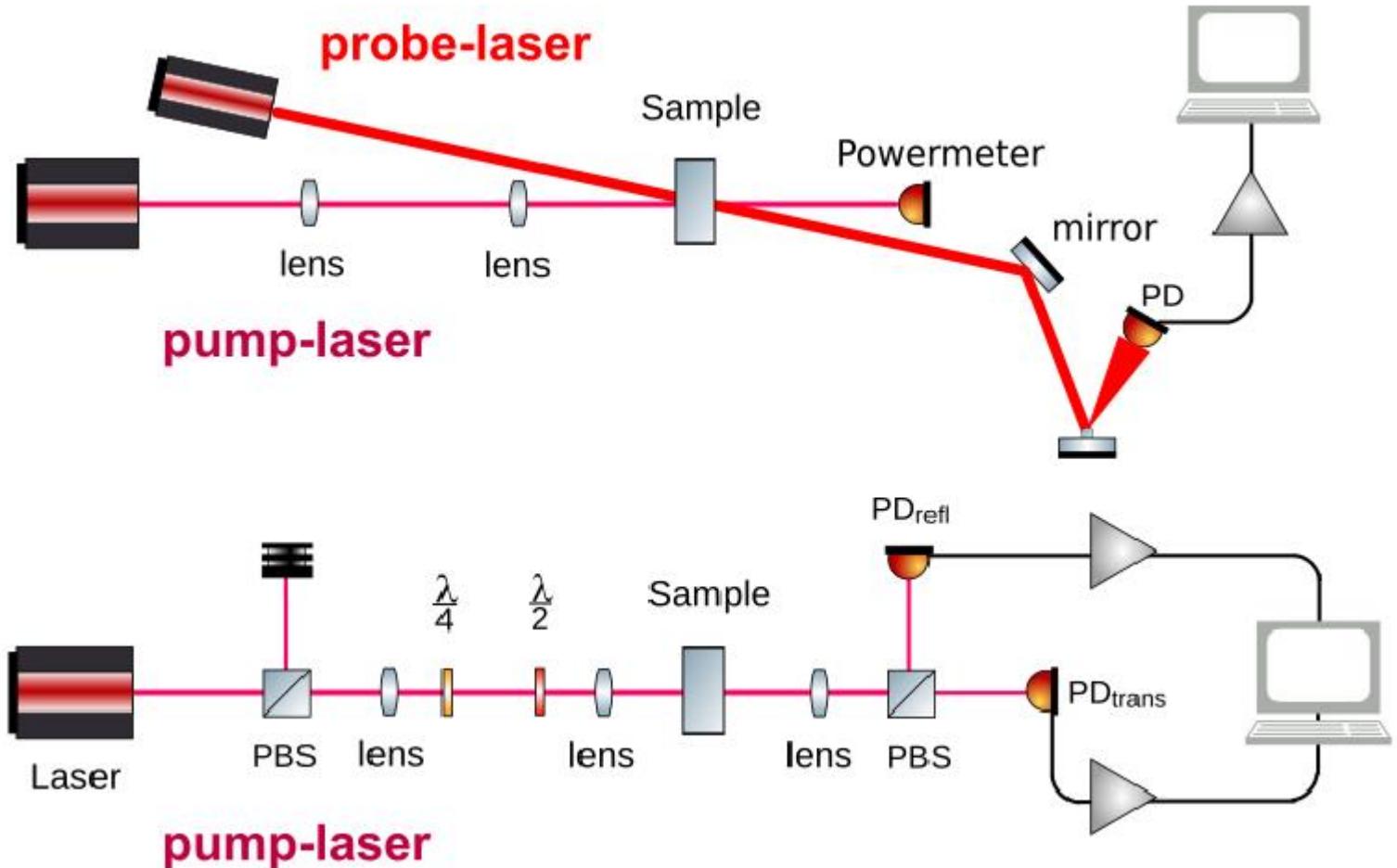
From TWE maps we estimated the expected p-pol at POP:

10.8% @POP (9.4%)
4.0% (4.8%)

[JGW- G1910369](#)

Characterization setup at NAOJ

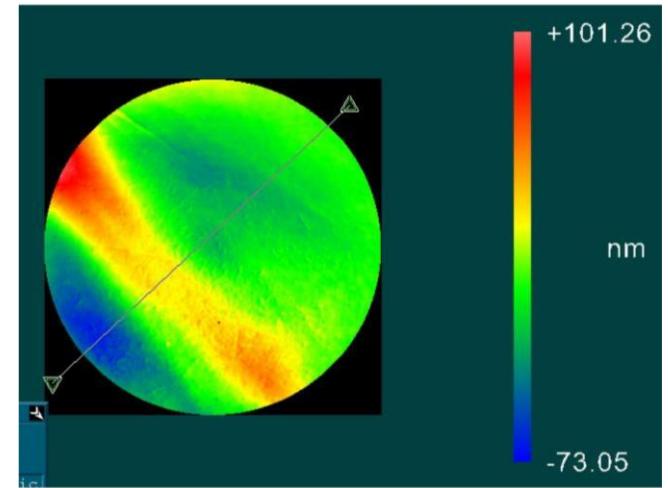
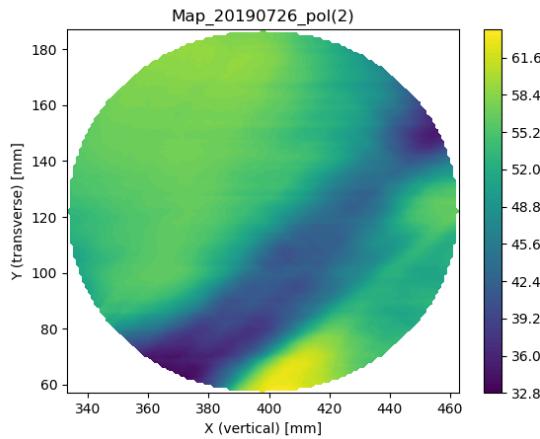
Absorption:
photothermal common-path interferometer



Birefringence:
Single-pass polarization rotation

Birefringence measurement setup

Spare ETMs:
characterized at Caltech
(TWE maps available)



STD @130mm = 6.38deg

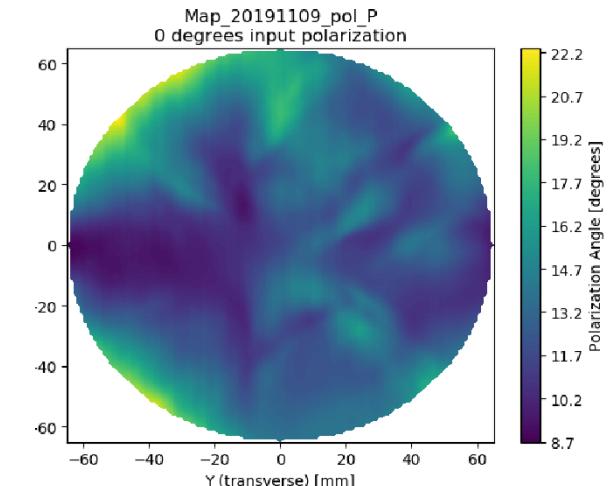
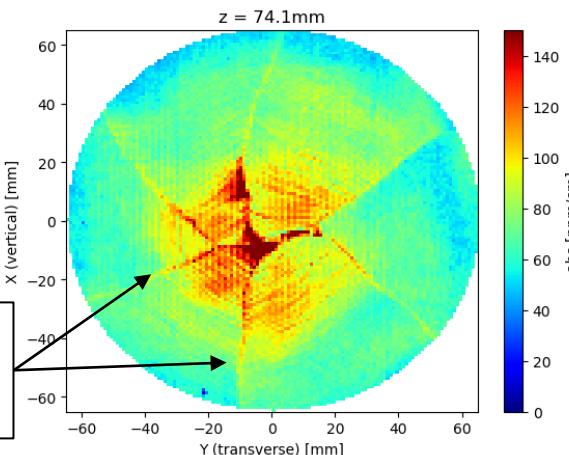
$$\theta = \frac{2\pi\Delta l_b}{\lambda} \rightarrow 18.8\text{nm}$$

RMS @140mm = 25.9nm

[JGW-T1909948](#)

Discarded ITM:
same growth method of
installed ITMs

M- and R-planes
intersections

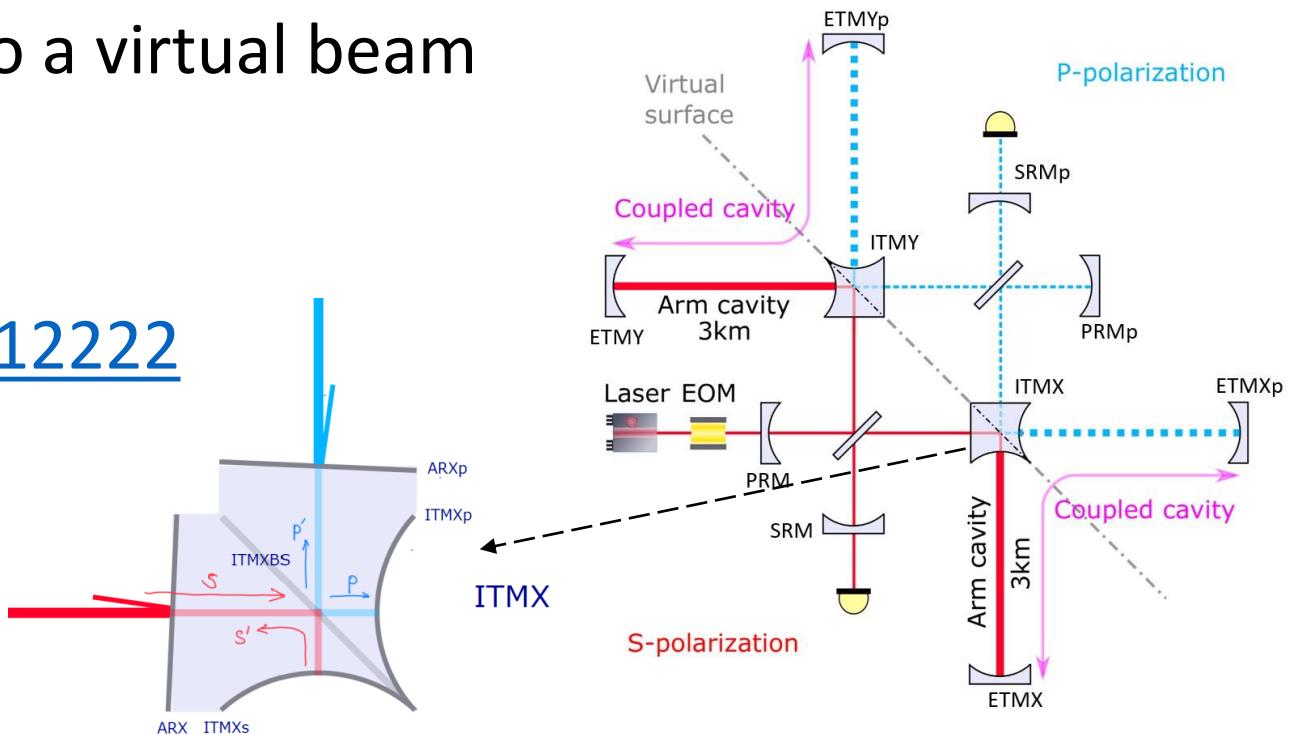


Simulating birefringence in KAGRA

Started ad-hoc simulation using Finesse (led by **Haoyu Wang** and **Kokeyama-san**):

- s-pol/p-pol ITFs
- Birefringence maps are applied to a virtual beam splitter (AOI=0deg)

More in [JGW-T2011792](#), [JGW-G2012222](#)



ITMs bulk birefringence recap

Causes:

- Local anisotropies of crystalline axis orientation (?)
- Local-stress (static) induced birefringence (?)

Consequences:

- Low PRG for sidebands
- A2L couplings (?)
- Increased scattered light (?)
- ...

Solution:

- Obtain more homogeneous bulks for new ITMs
- Develop post-growth processes to reduce inhomogeneities (?)

*(?) = investigation still ongoing

Collaborations to improve sapphire mirrors

Industries:

- Collaborations with several sapphire growth companies (Japan, Korea, US, Europe, ...)
- Difficult interaction since our requirements are extremely demanding and we want very few samples!

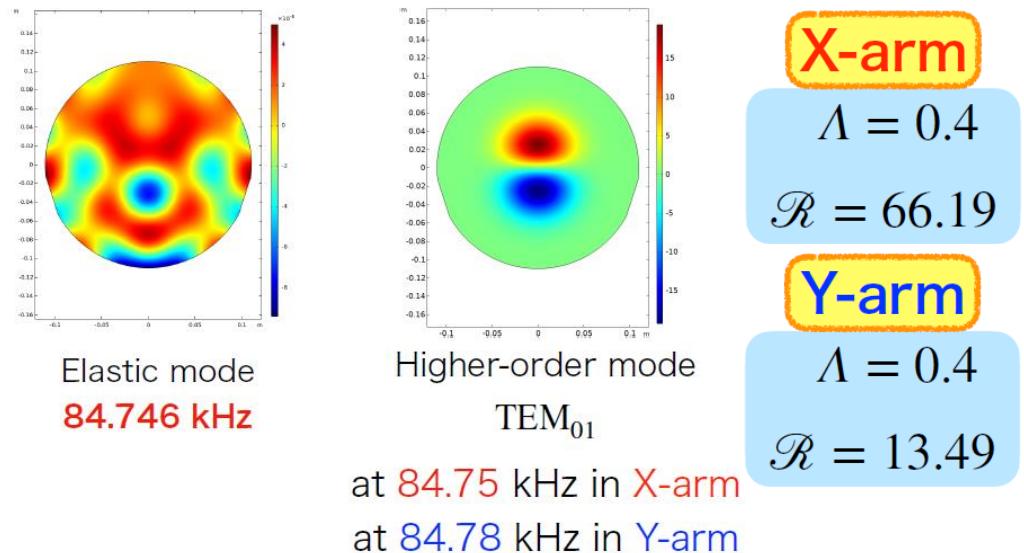
Research institutes:

- Collaboration with iLM (Lyon – FR) and with “ET” groups

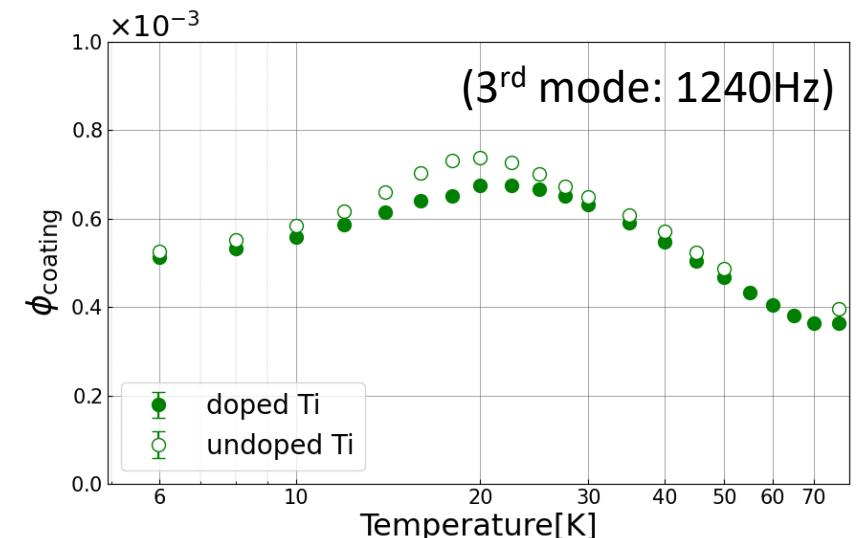
Follow the talks from Geppo,
Kheirreddine and Jerome for more...

Other MIR related activities

- Study of Parametric Instabilities
(see Kaihatsu-san's talk)



- Measurement of coating loss angle at cryogenic temperature
(see Mori-san's talk)



Questions?